

**Notice of References Cited**

Application/Control No.

09/744,793

Applicant(s)/Patent Under  
Reexamination  
MANSOUR ET AL.

Examiner

Yelena G. Gakh, Ph.D.

Art Unit

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	K	US-			
	L	US-			
	M	US-			

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